

Day : Tuesday
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PALM INTRANET

Time: 14:58:41

Inventor Name Search Result

Your Search was:

Last Name = IMAI

First Name = GENJI

Application#	Patent#	Status	Date Filed	Title	Inventor Name
<u>07831572</u>	Not Issued	161	02/04/1992	FILM FORMING PROCESS	IMAI, GENJI
<u>07931328</u>	Not Issued	161	08/18/1992	FILM RESIST FOR DIRECT WRITING AND ETCHING PROCESS USING SAID FILM RESIST	IMAI, GENJI
<u>08227346</u>	5496678	150	04/14/1994	PHOTOSENSITIVE COMPOSITIONS CONTAINING A POLYMER WITH CARBOXYL AND HYDROXYPHENYL GROUPS, A COMPOUND WITH MULTIPLE ETHYLENIC UNSATURATION AND A PHOTO-ACID GENERATOR	IMAI, GENJI
<u>08233443</u>	5527656	150	04/26/1994	POSITIVE TYPE ELECTRODEPOSITION PHOTORESIST COMPOSITIONS	IMAI, GENJI
<u>08382155</u>	5576148	150	02/01/1995	PROCESS FOR PRODUCTION OF PRINTED CIRCUIT BOARD	IMAI, GENJI
<u>08553978</u>	5650259	150	11/06/1995	PHOTOSENSITIVE COMPOSITIONS AND LIQUID DEVELOPMENT	IMAI, GENJI
<u>08610237</u>	5702872	250	03/04/1996	PROCESS FOR RESIST PATTERN FORMATION USING POSITIVE ELECTRODEPOSITION PHOTORESIST COMPOSITIONS	IMAI, GENJI
<u>08925675</u>	5939148	150	09/09/1997	VISIBLE LASER-CURABLE COMPOSITION	IMAI, GENJI
<u>08936840</u>	6054251	150	09/25/1997	PHOTOPOLYMERIZABLE COMPOSITION	IMAI, GENJI
<u>09131418</u>	6106999	150	08/10/1998	PHOTOSENSITIZER, VISIBLE LIGHT CURABLE RESIN COMPOSITION USING THE	IMAI, GENJI

				SAME, AND USE OF THE COMPOSITION	
<u>09145974</u>	<u>6124077</u>	150	09/03/1998	VISIBLE LIGHT-SENSITIVE COMPOSITIONS AND PATTERN FORMATION PROCESS	IMAI, GENJI
<u>09154047</u>	<u>6140025</u>	150	09/16/1998	NEGATIVE TYPE PHOTSENSITIVE RESIN COMPOSITION AND METHOD FOR FORMING RESIST PATTERN	IMAI, GENJI
<u>09167564</u>	<u>6187509</u>	150	10/07/1998	POSITIVE TYPE ELECTRODEPOSITION PHOTORESIST COMPOSITIONS AND PATTERN FORMATION PROCESS	IMAI, GENJI
<u>09193688</u>	Not Issued	161	11/18/1998	POSITIVE TYPE PHOTSENSITIVE RESIN COMPOSITION AND METHOD FOR FORMING RESIST PATTERN	IMAI, GENJI
<u>09245028</u>	<u>6093518</u>	150	02/05/1999	VISIBLE LASER-CURABLE COMPOSITION	IMAI, GENJI
<u>09418368</u>	<u>6630285</u>	150	10/14/1999	POSITIVE SENSITIVE RESIN COMPOSITION AND A PROCESS FOR FORMING A RESIST PATTERN THEREWITH	IMAI, GENJI
<u>09442741</u>	Not Issued	161	11/18/1999	METHOD FOR FORMING RESIST LAYER AND PROCESS FOR PRODUCING PRINTED CIRCUIT BOARD	IMAI, GENJI
<u>09573387</u>	<u>6670100</u>	150	05/18/2000	POSITIVE TYPE ACTINIC RAY-CURABLE DRY FILM AND PATTERN-FORMING METHOD BY USE OF THE SAME	IMAI, GENJI
<u>09582557</u>	<u>6664029</u>	150	08/30/2000	METHOD OF FORMING PATTERN	IMAI, GENJI
<u>09582846</u>	<u>6331376</u>	150	07/05/2000	ORGANIC-SOLVENT-BASED PHOTOCURABLE RESIST COMPOSITION AND RESIST PATTERN-FORMING METHOD	IMAI, GENJI
<u>09630191</u>	<u>6555286</u>	150	08/01/2000	POSITIVE TYPE ACTINIC RAY-SENSITIVE DRY FILM AND PATTERN-FORMING METHOD BY USE OF THE SAME	IMAI, GENJI
<u>09631428</u>	Not Issued	161	08/03/2000	Laminate for pattern formation	IMAI, GENJI

<u>09673316</u>	<u>6344307</u>	250	10/13/2000	Photosensitive resin composition	IMAI, GENJI
<u>09708407</u>	Not Issued	161	11/09/2000	Laminate for pattern formation	IMAI, GENJI
<u>09708408</u>	Not Issued	161	11/09/2000	Laminate for pattern formation	IMAI, GENJI
<u>09831892</u>	<u>6660457</u>	150	05/23/2001	METHOD OF FORMING CONDUCTIVE PATTERN	IMAI, GENJI
<u>09976278</u>	<u>6864035</u>	150	10/15/2001	POSITIVE PHOTOSENSITIVE RESIN COMPOSITION, POSITIVE PHOTOSENSITIVE DRY FILM AND METHOD OF FORMING PATTERN	IMAI, GENJI
<u>09976279</u>	<u>6913867</u>	150	10/15/2001	NEGATIVE PHOTOSENSITIVE RESIN COMPOSITION, NEGATIVE PHOTOSENSITIVE DRY FILM AND METHOD OF FORMING PATTERN	IMAI, GENJI
<u>09988252</u>	Not Issued	161	11/19/2001	Method of forming conductive pattern	IMAI, GENJI
<u>09996085</u>	<u>6699646</u>	150	09/13/2001	POSITIVE TYPE PHOTOSENSITIVE RESIN COMPOSITION AND METHOD FOR FORMING RESIST PATTERN	IMAI, GENJI
<u>10126512</u>	Not Issued	161	04/22/2002	Negative actinic ray-sensitive paste and pattern-forming method by use of the same	IMAI, GENJI
<u>10283306</u>	<u>6884570</u>	150	10/30/2002	POSITIVE TYPE ACTINIC RAY-CURABLE DRY FILM AND PATTERN-FORMING METHOD BY USE OF THE SAME	IMAI, GENJI
<u>10488075</u>	<u>7081486</u>	150	07/28/2004	METHOD OF PRODUCING POLYMER	IMAI, GENJI
<u>10488469</u>	<u>7078158</u>	150	03/04/2004	COMPOSITION FOR ACTIVATION ENERGY RAYS AND METHOD OF FORMING PATTERN	IMAI, GENJI
<u>10491541</u>	Not Issued	161	04/02/2004	OPTICAL WAVEGUIDE SHEET MATERIAL AND FABRICATION METHOD FOR SAME	IMAI, GENJI
<u>10561269</u>	Not Issued	19	01/01/0001	Process for purification treatment of wastewater containing organic substance	IMAI, GENJI
<u>10588717</u>	Not	30	08/08/2006	Photocurable resin composition for	IMAI, GENJI

	Issued			optical waveguide formation, photocurable dry film for optical waveguide formation, and optical waveguide	
10590737	Not Issued	30	08/25/2006	Curable resin composition for optical waveguide, curable dry film for optical waveguide, optical waveguide and method for forming core part for optical waveguide	IMAI, GENJI
10596826	Not Issued	19	01/01/0001	POLYMER AND PROCESS FOR PRODUCING POLYMER	IMAI, GENJI
10627891	6946234	150	07/28/2003	POSITIVE SENSITIVE RESIN COMPOSITION AND A PROCESS FOR FORMING A RESIST PATTERN THEREWITH	IMAI, GENJI
11018085	Not Issued	71	12/20/2004	Curable resin composition for optical waveguide, curable dry film for formal optical waveguide, optical waveguide, and, method for forming optical waveguide	IMAI, GENJI
11131981	Not Issued	30	05/18/2005	Polymerization reaction apparatus, and method of producing polymer using this apparatus	IMAI, GENJI
11185390	Not Issued	71	07/20/2005	Method of fabricating optical waveguide	IMAI, GENJI
11426257	Not Issued	160	06/23/2006	POLYMER AND PROCESS FOR PRODUCING POLYMER	IMAI, GENJI
11616705	Not Issued	25	12/27/2006	ACTIVE ENERGY RAY-CURABLE RESIN COMPOSITION AND METHOD FOR FORMING RESIST PATTERN	IMAI, GENJI
11632834	Not Issued	19	01/01/0001	Near infrared ray activation type positive resin composition	IMAI, GENJI

Inventor Search Completed: No Records to Display.

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